

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE	
In re application of: KAMALESH K. SRIVASTAVA, ET AL.	May 31, 2001 Examiner: <i>Ahmed</i>
Serial No. <i>09/870534</i> Filed: <i>5/31/01</i>	Group Art Unit: <i>1745</i>
Title: A METHOD OF IMPROVING UNIFORMITY OF ETCHING OF A FILM ON AN ARTICLE	IBM Corporation 2070 Route 52 Dept. 18G, Bldg. 300-482 Hopewell Junction, NY 12533

1003 U.S. PTO
09/870534



INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Pursuant to the duty of disclosure set forth in 37 C.F.R. 1.56, and further pursuant to the provisions of 37 C.F.R. 1.97 and 1.98, applicants hereby respectfully submit copies of the prior patents and publications as listed on Form PTO-1449, attached hereto.

In citing these documents, no representation is made nor intended as to the pertinency or non-pertinency of the art, that better art than that listed is not available, or that other art is not applicable.

The Examiner is respectfully requested to consider each reference and initial a copy of Form PTO-1449 and return a copy of same to Applicants.

Respectfully submitted,
KAMALESH K. SRIVASTAVA, ET AL.

by: *[Signature]*
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I HEREBY CERTIFY THAT THIS DISCLOSURE STATEMENT IS BEING DELIVERED WITH THE UNITED STATES POSTAL SERVICE AS EXPRESS MAIL IN AN ENVELOPE ADDRESSED TO THE ASSISTANT COMMISSIONER FOR PATENTS, WASHINGTON, D.C. 20231, ON	
Date of Deposition: <u>May 31, 2001</u>	Name of Person Making Deposition: <u>Karen Cing-Mars</u>
Express Mail No: <u>EF383030292US</u>	Signature: <i>[Signature]</i> <u>5/31/01</u>